

LIST OF ART CITED BY APPLICANT (PTO-1449)	ATTY. DOCKET NO. 501.37370CC4	APPLICATION NO. TBD
	APPLICANT OHASHI, et al.	
	FILING DATE January 14, 2004	Expected GROUP 2824

U.S. PATENT DOCUMENTS

EXAMINER'S INITIALS	PATENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE
lm	6,068,879 /	5/30/2000	Pasch			
	5,854,140 /	12/29/1998	Jaso, et al.			
	5,573,633 /	11/12/1996	Gambino, et al.			
	6,117,775 /	9/12/2000	Kondo, et al.			
	6,140,239 /	10/31/2000	Avanzino, et al.			
	6,082,373 /	7/4/2000	Sakuri, et al.			
	6,117,784 /	9/12/2000	Uzoh			
	6,013,578 /	1/11/2000	Jun			
	6,028,360 /	2/22/2000	Nakamura, et al.			
	6,376,345 /	4/23/2002	Ohashi, et al.			
	6,153,043 /	11/28/2000	Edelstein, et al.			
	5,084,071 /	1/28/1992	Nenadic, et al.			
	5,139,571 /	8/18/1992	Deal, et al.			
	5,144,498 /	9/1/1992	Vincent			
	5,340,370 /	8/23/1994	Cadien, et al.			
	5,480,748 /	1/2/1996	Bakeman, Jr., et al.			
	5,527,423 /	6/18/1996	Neville, et al.			
	5,575,837 /	11/19/1996	Kodama, et al.			
	5,931,723 /	8/3/1999	Katsuoka, et al.			
	6,146,135 /	11/14/2000	Watanabe, et al.			
✓	5,549,798 /	8/27/1996	Kitajima, et al.			

FOREIGN PATENT DOCUMENTS

EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						Yes	No
lm	251317/1999	1999	Japan			X	

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

lm	Ohmura, et al. "Electronic Materials", Issued in May 1996 by Association of Industrial Researches, pp 53-55
lm	Tsujimura, et al. "Electronic Materials" Issued in May 1996, pp 62-65
lm	Hirakura, "Electronic Materials" Issued in May 1996, pp 33-35

EXAMINER lm	DATE CONSIDERED 4-12-5
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LIST OF ART CITED BY APPLICANT (PTO-1449)				ATTY. DOCKET NO. 501.37370CC4		APPLICATION NO. TBD	
				APPLICANT OHASHI, et al.			
				FILING DATE January 21, 2004		Expected GROUP 2824	

U.S. PATENT DOCUMENTS						
EXAMINER'S INITIALS	PATENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE
	5,833,831 /	11/10/1998	Kitajima, et al.			
	6,485,808 /	11/26/2002	Anzai, et al.			
	5,240,749 /	08/31/1993	Chow			
	6,475,914 /	11/5/2002	Han			
	6,468,909 /	10/22/2002	Marshall			
	6,461,226 /	10/8/2002	Yi			
	6,444,569 /	09/3/2002	Farkas, et al.			
	6,432,823 /	08/13/2002	Huynh, et al.			
	6,429,130 /	08/6/2002	Chuang			
	6,413,871 /	07/2/2002	M'Saad, et al.			
	6,410,438 /	06/25/2002	Ozaki			
	6,458,674 /	10/01/2002	Ohashi, et al.			
	6,531,400 /	03/11/2003	Ohashi, et al.			

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EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						Yes	No
	3083809 /	10/8/1999	Japan				X
	2-257631 /	10/18/1990	Japan			X	
	5-47735 /	2/26/1993	Japan				X
	7-256260 /	10/9/1995	Japan				X
	1-164039 /	6/28/1989	Japan			X	
	8-64594 /	3/08/1996	Japan			X	
	6-188203 /	7/08/1994	Japan			X	
	7-135192 /	5/23/1995	Japan			X	

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)	

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Substitute for form 1449A/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(fill as many sheets as necessary)</i>		Complete If Known	
		Application Number	10/760,292
		Filing Date	1/21/2004
		First Named Inventor	N. Ohashi, et al.
		Art Unit	2812
Examiner Name	TBD		
Sheet 1 of 1	Attorney Docket Number	501.37370CC4	

U.S. PATENT DOCUMENTS					
Examiner Initials ¹	Cite No. ¹	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code ² (if known)			
		US-			
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FOREIGN PATENT DOCUMENTS						
Examiner Initials ¹	Cite No. ¹	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	Abstract/Translation
		Country Code ² -Number ³ -Kind Code ⁴ (if known)				
lm		JP 7-135192	5/23/1995	Sony Corp.		X

NON PATENT LITERATURE DOCUMENTS			
Examiner Initials ¹	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published	T ²
lm		Hayasaka, et al. "Mechanism of Corrosion in Al-Si-Cu", ULSI Research Center, July 1991, pages 1571-1575	
lm		Japanese Office Action for corresponding Japanese Application No. JP 1998-209857, dated June 1, 2004, with English-language equivalent	

Examiner Signature	lm	Date Considered	04-07-05
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